

<b>Notice of References Cited</b>	Application/Control No. 09/645,903	Applicant(s)/Patent Under Reexamination LI, LI	
	Examiner Matthew W. Such	Art Unit 2891	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-			
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	D	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Burkman, D.C., et al "Aqueous Cleaning Processes." Chapter 3. HANDBOOK OF SEMICONDUCTOR WAFER CLEANING TECHNOLOGY. Ed. Werner Kern. Werner Kern Associates: East Windsor, New Jersey. (1983): pp. 109-151.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.